

FORM PTO-1449 (REV. 7-2001) JC1203		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. 854063.666		APPLICATION NO. 10/081,134	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANTS Ernesto Lasalandra et al.			
				FILING DATE February 20, 2002		GROUP ART UNIT 2858	
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
ah	AA	4,054,833	10/18/77	Briefer	324	60 C	
am	AB	4,860,232	08/22/89	Lee et al.	364	571.04	
am	AC	2003/0052699	03/20/03	Lasalandra et al.	324	662	
	AD						
	AE						
	AF						
	AG						
	AH						
	AJ						
	AJ						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION		
					YES	NO	
ah	AK	2 706 038	12/09/94	FR (+ Abstract in English)		X	
	AL						
	AM						
	AN						
	AO						
OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
	AP						
	AQ						
	AR						
EXAMINER <i>ah</i>				DATE CONSIDERED 2/3/04			
* EXAMINER: Initial if reference considered, whether or not criteria is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant(s).							

FORM PTO-1449 (REV. 7-80)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. 854063.666		APPLICATION NO. 10/081,134	
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	AK						
	AL						
	AM						
	AN						
	AO						
OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
am	AP	Lemkin, M. et al., "A Three-Axis Micromachined Accelerometer with a CMOS Position-Sense Interface and Digital Offset-Trim Electronics," <i>IEEE Journal of Solid-State Circuits</i> , 34(4):456-468, April 1999.					
	AQ						
	AR						
EXAMINER <i>Amg He</i>				DATE CONSIDERED <i>6/11/03</i>			
* EXAMINER: Initial if reference considered, whether or not criteria is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant(s).							